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***P*-Methyl-*P*-phenylpropylphosphine selenide: correction of a printer's error.** By Z. GALDECKI and M. L. GŁÓWKA, *Institute of General Chemistry, Technical University, 36 Żwirki, 90-924 Łódź, Poland* and J. MICHALSKI, A. OKRUSZEK and W. J. STEC, *Polish Academy of Science, Centre of Molecular and Macromolecular Studies, 90-362 Łódź, Poland*

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Improved reproductions are given of Figs. 1 and 2 of the paper by Galdecki, Głowska, Michalski, Okruszek & Stec [*Acta Cryst.* (1977), **B33**, 2322–2324].

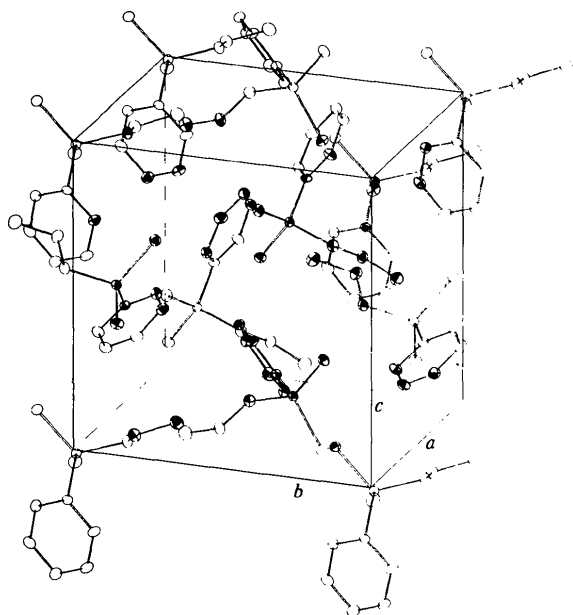


Fig. 1. Computer drawing of *P*-methyl-*P*-phenylpropylphosphine selenide. The thermal ellipsoids have been scaled to include 40% probability. Hydrogen atoms are omitted for clarity.

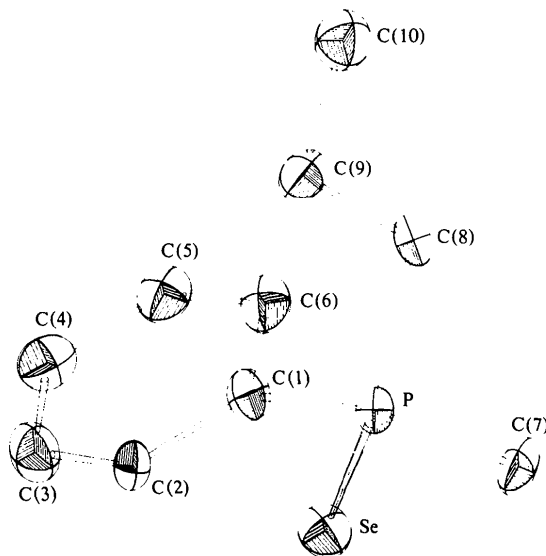


Fig. 2. Projection of the unit-cell contents.